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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Attorney Docket Number P30037 Application Data Sheet 37 CFR 1.76 Application Number Title of Invention EPITAXIAL WAFER AND METHOD FOR PRODUCING SAME The application data sheet is part of the provisional or nonprovisional application for which it is being submitted. The following form contains the bibliographic data arranged in a format specified by the United States Patent and Trademark Office as outlined in 37 CFR 1.76. This document may be completed electronically and submitted to the Office in electronic format using the Electronic Filing System (EFS) or the document may be printed and included in a paper filed application, Secrecy Order 37 CFR 5.2 Portions or all of the application associated with this Application Data Sheet may fall under a Secrecy Order pursuant to 37 CFR 5.2 (Paper filers only. Applications that fall under Secrecy Order may not be filed electronically.) Applicant Information: Remove Applicant 1 Legal Representative under 35 U.S.C. 117 Party of Interest under 35 U.S.C. 118 Applicant Authority (•) Inventor Prefix Given Name Middle Name **Family Name** Suffix Yasuo FUKUDA O US Residency Residence Information (Select One) Non US Residency Active US Military Service City Tokyo Country Of Residencei Citizenship under 37 CFR 1.41(b) JP. Mailing Address of Applicant: Address 1 c/o SUMCO CORPORATION Address 2 2-1, Shibaura 1-chome, Minato-ku State/Province City Tokyo Postal Code 105-8634 Country Remove Applicant 2 Applicant Authority 

Inventor ○Legal Representative under 35 U.S.C. 117 Party of Interest under 35 U.S.C. 118 Prefix Given Name Middle Name **Family Name** Suffix Makoto **TAKEMURA** Residence Information (Select One) ∪S Residency Non US Residency Active US Military Service City JΡ Tokyo Country Of Residence Citizenship under 37 CFR 1.41(b) i Mailing Address of Applicant: Address 1 c/o SUMCO CORPORATION Address 2 2-1, Shibaura 1-chome, Minato-ku State/Province City Tokyo Postal Code 105-8634 Country Remove Applicant 3 Applicant Authority ( Inventor Legal Representative under 35 U.S.C. 117 Party of Interest under 35 U.S.C. 118 Prefix. Given Name Middle Name Family Name Suffix OKUDA Koichi

∪S Residency

Country Of Residence

Non US Residency

JΡ

Active US Military Service

Tokyo

Residence Information (Select One)

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Address 2	:	2-1, Shibaura 1-	chome	, Minato-k	cu .										
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Application Data Sheet 37 CFR 1.76		Attorney Docket Number	P30037
		Application Number	
Title of Invention	EPITAXIAL WAFER AND ME	ETHOD FOR PRODUCING SAM	1E
Customer Number	07055		

#### **Domestic Priority Information:**

This section allows for the applicant to claim benefit under 35 U.S.C. 119(e), 120, 121, or 365(c). Providing this information in the application data sheet constitutes the specific reference required by 35 U.S.C. 119(e) or 120, and 37 CFR 1.78(a)(2) or CFR 1.78(a) (4), and peed not otherwise be made part of the specification

(4), and need not otherwise be made part of the specification.						
Prior Application Status			Remove			
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### **Foreign Priority Information:**

This section allows for the applicant to claim benefit of foreign priority and to identify any prior foreign application for which priority is not claimed. Providing this information in the application data sheet constitutes the claim for priority as required by 35 U.S.C. 119(b) and 37 CFR 1.55(a).

	Rei	nove					
Application Number	Country i	Parent Filing Date (YYYY-MM-DD)	Priority Claimed				
2003/413737	JP	2003-12-11	Yes ○ No				
Additional Foreign Priority Data may be generated within this form by selecting the Add button.							

# **Assignee Information:**

Providing this information in the application data sheet does not substitute for compliance with any requirement of part 3 of Title 37 of the CFR to have an assignment recorded in the Office.

of the CFR to have all as	Sigrili	ient recorded in the Office.					
Assignee 1					Remove		
If the Assignee is an Organization check here.							
Organization Name	SU	IMCO CORPORATION					
Mailing Address Info	rmati	ion:					
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Address 2							
City		Tokyo	State/Province				
Country   JP			Postal Code	105-8634			
Phone Number			Fax Number				
Email Address				,			
Additional Assignee Data may be generated within this form by selecting the Add button.							

## Signature:

A signature of the applicant or representative is required in accordance with 37 CFR 1.33 and 10.18. Please see 37 CFR 1.4(d) for the form of the signature.

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Title of Invention			Application Number	
	Title of Invention	EPITAXIAL WAFER AND ME	THOD FOR PRODUCING SAM	1E

Signature	/William S. Boshnick/			Date (YYYY-MM-DD)	2006-06-08
First Name	William S.	Last Name	Boshnick	Registration Number	44,550

This collection of information is required by 37 CFR 1.76. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 23 minutes to complete, including gathering, preparing, and submitting the completed application data sheet form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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- 7. A record from this system of records may be disclosed, as a routine use, to the Administrator, General Services, or his/her designee, during an inspection of records conducted by GSA as part of that agency's responsibility to recommend improvements in records management practices and programs, under authority of 44 U.S.C. 2904 and 2906. Such disclosure shall be made in accordance with the GSA regulations governing inspection of records for this purpose, and any other relevant (i.e., GSA or Commerce) directive. Such disclosure shall not be used to make determinations about individuals.
- 8. A record from this system of records may be disclosed, as a routine use, to the public after either publication of the application pursuant to 35 U.S.C. 122(b) or issuance of a patent pursuant to 35 U.S.C. 151. Further, a record may be disclosed, subject to the limitations of 37 CFR 1.14, as a routine use, to the public if the record was filed in an application which became abandoned or in which the proceedings were terminated and which application is referenced by either a published application, an application open to public inspections or an issued patent.
- A record from this system of records may be disclosed, as a routine use, to a Federal, State, or local law enforcement agency, if the USPTO becomes aware of a violation or potential violation of law or regulation.